

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2393	PRIORITY SERIAL NO. 09/597 604 10/659,596	
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U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
TL	AA	6,251,754	Kobayashi et al.				
	AB	6,245,161	Henley et al.				
	AC	5,374,581	Ichikawa et al.				
	AD	4,891,329	Reisman et al.				
	AE	6,130,031	Yonehara				
	AF	6,083,324	Henley et al.				
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	AH						
	AI						
	AJ						
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	AM						

FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
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PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
M122-2393PRIORITY SERIAL NO.
09/392,604LIST OF ART CITED BY APPLICANT
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*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TL	AA	5,298,449	03/94	Kikuchi			
	AB	5,374,564	12/94	Bruei			
	AC	5,855,693	01/99	Murari et al.			
	AD	5,877,070	03/99	Goesle et al.			
	AE	5,882,987	03/99	Srikrishnan			
	AF	5,894,152	04/99	Jaso et al.			
	AG	5,953,622	09/99	Lee et al.			
	AH	6,004,406	12/99	Kobayashi et al.			
	AI	6,309,945 B1	10/01	Sato et al.			
	AJ	6,429,070 B1	08/02	Gonzalez et al.			
	AK	6,384,439 B1	05/02	Walker			
		6,423,992 B2	07/02	Fukuda, et al.			
	AL	5,998,847	12/99	Assaderaghi, et al.			

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TL	AR		Gösele, U. et al., "Semiconductor Wafer Bonding: Science, Technology, and Applications", Electrochemical Society Proceedings
			Vol. 97-36, (©1998), pp. 400-425, 436-445.
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